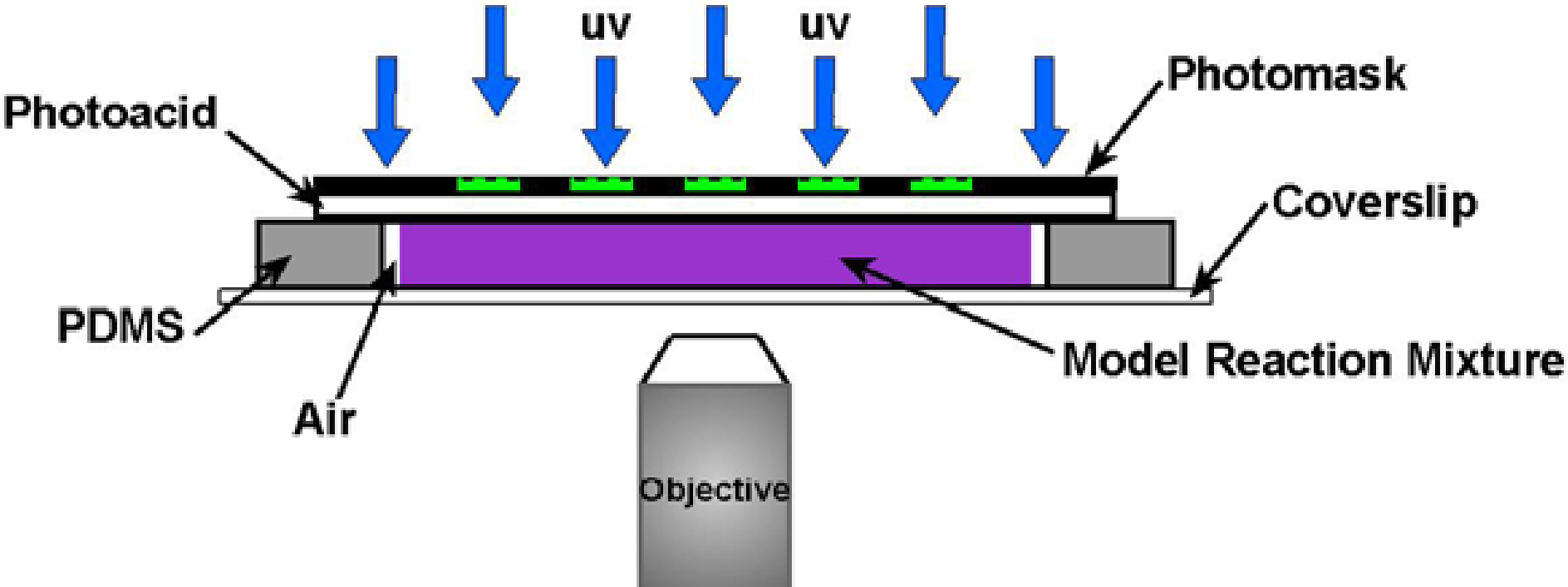
uv
uv
Photomask
Photoacid
Coverslip
PDMS
Model Reaction Mixture
Air
Objective